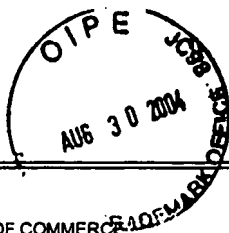


FORM PTO 1449 (modified)		ATTY DOCKET NO. 03500.017976		APPLICATION NO. 10/806,157	
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/Thanh Truc Trinh/			(07/12/2007)		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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